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Product Name:

Wafer total contain for cell washing sys 6640014919330 sterile 240s

Special Features:

For cell washing system 6640014919330 acp 215 automated cell processor; the copper wafer used by the total containment device (tcd) when it makes a sterile tubing connection; the wafer is equipped with and fds-mandated mylar seal which is designed to ensure the integrity of the sterile connection; the mylar seal is consumed once the tcd makes a connection, anew wafer must be used each time the tcd makes a sterile tubing connection

Shelf Life:

N/a

Unit Of Measure:

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Demilitarization:

No